

DOCKET NO: 241280US2S DIV



RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2818

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

TSUTOMU SATO ET AL. :

EXAMINER: NGO, N. V.

SERIAL NO: 10/637,665 :

FILED: AUGUST 11, 2003 :

GROUP ART UNIT: 2818

FOR: SEMICONDUCTOR DEVICE :
FORMED IN SEMICONDUCTOR
LAYER ARRANGED ON
SUBSTRATE WITH ONE OF
INSULATING FILM AND CAVITY
INTERPOSED BETWEEN THE
SUBSTRATE AND THE
SEMICONDUCTOR LAYER

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.